



ELSEVIER

Applied Surface Science 90 (1995) 522-526

applied
surface science

Author index

- Aarik, J. and H. Siimon, Erratum to "Characterization of adsorption in flow type atomic layer epitaxy reactor" [Appl. Surf. Sci. 81 (1994) 281] 90 (1995) 109
- Abbas, N.M., see Mohamed, M.H. 90 (1995) 409
- Abdillahi, M.M., see Mohamed, M.H. 90 (1995) 409
- Abon, M., see Debaugue, Y. 90 (1995) 15
- Adnot, A., see Lamontagne, B. 90 (1995) 447
- Ahlgren, T., K. Väkeväinen, J. Räisänen, E. Rauhala and J. Keinonen, Range profiles of 6-10 MeV ^{15}N ions implanted in silicon 90 (1995) 419
- Alford, T.L., see Russell, S.W. 90 (1995) 455
- Aliev, V.S., M.R. Baklanov and V.I. Bukhtiyarov, Silicon surface cleaning using XeF_2 gas treatment 90 (1995) 191
- Allinger, Th., see Engelhard, H. 90 (1995) 89
- Arpatzanis, N., see Thurzo, I. 90 (1995) 39
- Ascherl, M., see Wang, P.W. 90 (1995) 413
- Badaye, M., see Wang, F. 90 (1995) 123
- Baev, A.A., see Tutov, E.A. 90 (1995) 303
- Baklanov, M.R., see Aliev, V.S. 90 (1995) 191
- Basiuk, E.V., see Dmitruk, N.L. 90 (1995) 489
- Bater, S., see Wang, P.W. 90 (1995) 413
- Batirev, I.G., see Leiro, J.A. 90 (1995) 515
- Bertolini, J.C., see Debaugue, Y. 90 (1995) 15
- Bolmont, D., see Hong, S. 90 (1995) 65
- Bradley, R.H., Surface studies of Cu/Cr/Ag impregnated microporous carbons 90 (1995) 271
- Bradshaw, A.M., see Keil, M. 90 (1995) 377
- Brocherieux, A., O. Dessaux, P. Goudmand, L. Gengembre, J. Grimblot, M. Brunel and R. Lazzaroni, Characterization of nickel films deposited by cold remote nitrogen plasma on acrylonitrile-butadiene-styrene copolymer 90 (1995) 47
- Brown, N.M.D. and Z.-H. Liu, An investigation using atomic force microscopy and X-ray photoelectron spectroscopy of the modification of the surface of mica with an argon RF-plasma discharge 90 (1995) 155
- Brunel, M., see Brocherieux, A. 90 (1995) 47
- Bukhtiyarov, V.I., see Aliev, V.S. 90 (1995) 191
- Büssenschütt, A., see Zielasek, V. 90 (1995) 117
- Castle, J.E., see Salvi, A.M. 90 (1995) 333
- Caudano, R., see Lamontagne, B. 90 (1995) 481
- Chen, C.S., see Mar, S.Y. 90 (1995) 497
- Chen, X.G., see Xiao, X.R. 90 (1995) 321
- Condorelli, G.G., see Gulino, A. 90 (1995) 289
- Craig, Jr., J.H., see Wang, P.W. 90 (1995) 413
- Davies, R.E., see Smith, G.C. 90 (1995) 357
- Debaugue, Y., M. Abon, J.C. Bertolini, J. Massardier and A. Rochefort, Synergistic alloying behaviour of $\text{Pd}_{50}\text{Cu}_{50}$ single crystals upon adsorption and co-adsorption of CO and NO 90 (1995) 15
- Deldime, M., J.-L. Dewez, Y.-J. Schneider and J. Marchand-Brynaert, Reactivity assay of surface carboxyl chain-ends of poly(ethylene terephthalate) (PET) film and track-etched microporous membranes using fluorine labelled- and/or ^3H -labelled derivatization reagents: tandem analysis by X-ray photoelectron spectroscopy (XPS) and liquid scintillation counting (LSC) 90 (1995) 1
- Desimoni, E., see Salvi, A.M. 90 (1995) 333
- Dessaux, O., see Brocherieux, A. 90 (1995) 47
- Dewez, J.-L., see Deldime, M. 90 (1995) 1
- Dietrich, D., see Schlottig, F. 90 (1995) 129
- Dimitrakis, P., see Thurzo, I. 90 (1995) 39
- Dmitruk, N.L., E.V. Basiuk, G.Ya. Kolbasov, O.A. Yakubtsov, I.A. Molchanovskii and T.A. Taranets, Morphology, atomic composition and photoelectric properties of the microrelief InP-electrolyte interface 90 (1995) 489
- Duś, R., E. Nowicka, W. Lisowski and Z. Wolfram, Atomic hydrogen adsorption on sintered thin copper films 90 (1995) 277
- Easwarakhanthan, T., S. Ravelet and P. Renard, An ellipsometric procedure for the characterization of very thin surface films on absorbing substrates 90 (1995) 251
- Egdell, R.G., see Gulino, A. 90 (1995) 289
- Egdell, R.G., see Taverner, A.E. 90 (1995) 383

- Engelhard, H., F. Stietz, S. Sloboshanin, V. Persch, Th. Allinger, J.A. Schaefer and A. Goldmann, Interfacial reaction of Ag with the InP(100)4 × 2 surface – a photoemission study 90 (1995) 89
- Fragalà, I., see Gulino, A. 90 (1995) 289
- Gardella, Jr., J.A., see Li, J.-X. 90 (1995) 205
- Gengembre, L., see Brocherieux, A. 90 (1995) 47
- Geus, J.W., see Van Kooten, W.E.J. 90 (1995) 137
- Geus, J.W., see Van Wijk, R. 90 (1995) 261
- Gewinner, G., see Hong, S. 90 (1995) 65
- Ghosh, T.B., see Sreemany, M. 90 (1995) 241
- Giardini-Guidoni, A., see Teghil, R. 90 (1995) 505
- Gijzeman, O.L.J., see Van Kooten, W.E.J. 90 (1995) 137
- Gijzeman, O.L.J., see Van Wijk, R. 90 (1995) 261
- Gol'berg, S.M., see Sobol, E.N. 90 (1995) 235
- Goldmann, A., see Engelhard, H. 90 (1995) 89
- Gorenstein, A., see Julien, C. 90 (1995) 389
- Görts, P.C., see Van Wijk, R. 90 (1995) 261
- Goudmand, P., see Brocherieux, A. 90 (1995) 47
- Grimblot, J., see Brocherieux, A. 90 (1995) 47
- Guay, D., see Lamontagne, B. 90 (1995) 481
- Guczi, L., see Sundararajan, R. 90 (1995) 165
- Guesdon, J.P., see Julien, C. 90 (1995) 389
- Gulino, A., G.G. Condorelli, I. Fragalà and R.G. Egdell, Surface segregation of Sb in doped TiO₂ rutile 90 (1995) 289
- Gulino, A., see Taverner, A.E. 90 (1995) 383
- Habraken, F.H.P.M., see Van Wijk, R. 90 (1995) 261
- Hariharan, K., see Van Bakel, G.P.E.M. 90 (1995) 95
- Haslingerová, I., see Pingo, M. 90 (1995) 373
- Heinonen, M.H., see Leiro, J.A. 90 (1995) 515
- Henzler, M., see Zielasek, V. 90 (1995) 117
- Hofmann, A., see Schlottig, F. 90 (1995) 129
- Hofmann, S. and M.G. Stepanova, Preferential sputtering of argon ion bombarded Ni₃Al and TaSi₂ 90 (1995) 227
- Hong, S., C. Pirri, P. Wetzel, D. Bolmont and G. Gewinner, Medium energy electron diffraction and X-ray photoelectron diffraction study of pseudomorphic Fe silicides grown on Si(111). Evidence of Fe vacancy formation 90 (1995) 65
- Hono, K., see Ringer, S.P. 90 (1995) 107
- Hood, G.M., see Zou, H. 90 (1995) 59
- Hu, X. and Z. Lin, Hydrogen adsorption induced phase transitions on Si(100)-c(8 × 8): temperature dependence studied by LEED 90 (1995) 111
- Huang, M., S. Kaliaguine and S. Suppiah, Surface interaction between H₂ and CO₂ over silicalite-supported platinum 90 (1995) 393
- Huang, Y.S., see Mar, S.Y. 90 (1995) 497
- Ignatiev, A., see Zomorrodian, A. 90 (1995) 343
- Imai, S., see Sugahara, S. 90 (1995) 349
- Ivanov, I., see Julien, C. 90 (1995) 389
- Jackson, S.T. and R.G. Nuzzo, Determining hybridization differences for amorphous carbon from the XPS C 1s envelope 90 (1995) 195
- Julien, C., J.P. Guesdon, A. Gorenstein, A. Khelfa and I. Ivanov, The influence of the substrate material on the growth of V₂O₅ flash-evaporated films 90 (1995) 389
- Kadoshima, M., see Sugahara, S. 90 (1995) 349
- Kafader, U., H. Sirringhaus and H. von Känel, In situ DC-plasma cleaning of silicon surfaces 90 (1995) 297
- Kaliaguine, S., see Huang, M. 90 (1995) 393
- Kalomiros, J.A., see Kennou, S. 90 (1995) 283
- Keil, M., J.J. Paggel, Th. Schedel-Niedrig, S. Yokoyama, H. Sotobayashi and A.M. Bradshaw, The structure of PMDA-PDA polyimide monolayers adsorbed on gold surfaces 90 (1995) 377
- Keinonen, J., see Ahlgren, T. 90 (1995) 419
- Kennou, S., S. Ladas, E.C. Paloura and J.A. Kalomiros, Characterization of ex-situ hydrogenated amorphous SiC thin films by X-ray photoelectron spectroscopy 90 (1995) 283
- Khelfa, A., see Julien, C. 90 (1995) 389
- Kim, C.O., see Kim, T.W. 90 (1995) 75
- Kim, T.W., Y.S. Yoon, S.S. Yom and C.O. Kim, Ferroelectric BaTiO₃ films with a high-magnitude dielectric constant grown on p-Si by low-pressure metalorganic chemical vapor deposition 90 (1995) 75
- Kitai, M.S., see Sobol, E.N. 90 (1995) 235
- Kitamura, T., see Sugahara, S. 90 (1995) 349
- Knoll, W., see Piscevic, D. 90 (1995) 425
- Kolbasov, G.Ya., see Dmitruk, N.L. 90 (1995) 489
- Koltay, E., see Sundararajan, R. 90 (1995) 165
- Ladas, S., see Kennou, S. 90 (1995) 283
- Lamontagne, B., F. Semond, A. Adnot and D. Roy, SIMS investigation of the Si(111) oxidation promoted by potassium overlayers 90 (1995) 447
- Lamontagne, B., D. Guay, D. Roy, R. Sporken and R. Caudano, AFM and XPS characterization of the Si(111) surface after thermal treatment 90 (1995) 481
- LaPierre, R.R., B.J. Robinson and D.A. Thompson, Lateral composition modulation in InGaAsP deposited by gas source molecular beam epitaxy on (100)- and (h11)-oriented InP substrates 90 (1995) 437
- Lawall, R., see Piscevic, D. 90 (1995) 425
- Lazzaroni, R., see Brocherieux, A. 90 (1995) 47

- Leiro, J.A., M.H. Heinonen and I.G. Batirev,
Surface segregation and core-level shift
of a Pd-Rh alloy studied by XPS 90 (1995) 515
- Li, F.M., see Wu, J.D. 90 (1995) 81
- Li, J., see Russell, S.W. 90 (1995) 455
- Li, J.-X., J.A. Gardella, Jr. and P.J. McKe-
own, A quantitative time-of-flight sec-
ondary ion mass spectrometry study of
ion formation mechanisms using acid-
base alternating Langmuir-Blodgett
films 90 (1995) 205
- Liley, M., see Piscevic, D. 90 (1995) 425
- Lin, Y., see Xiao, X.R. 90 (1995) 321
- Lin, Z., see Hu, X. 90 (1995) 111
- Lisowski, W., see Duś, R. 90 (1995) 277
- Liu, Z.-H., see Brown, N.M.D. 90 (1995) 155
- Loh, T.E., see Lu, Y.F. 90 (1995) 217
- Low, T.S., see Lu, Y.F. 90 (1995) 217
- Lu, Y.F., T.E. Loh, H.G. Soh and T.S. Low,
Laser-induced temperature rise in
Gaussian-shaped holes 90 (1995) 217
- Lu, Z.-H., see Yang, X.-M. 90 (1995) 175
- Mar, S.Y., C.S. Chen, Y.S. Huang and K.K.
Tiong, Characterization of RuO₂ thin
films by Raman spectroscopy 90 (1995) 497
- Marchand-Brynaert, J., see Deldime, M. 90 (1995) 1
- Marotta, V., see Teghil, R. 90 (1995) 505
- Marx, G., see Schlottig, F. 90 (1995) 129
- Massardier, J., see Debauge, Y. 90 (1995) 15
- Matsumura, M., see Sugahara, S. 90 (1995) 349
- McKeown, P.J., see Li, J.-X. 90 (1995) 205
- Mele, A., see Teghil, R. 90 (1995) 505
- Mens, A.J.M., see Van Wijk, R. 90 (1995) 261
- Mesarwi, A., see Zomorrodian, A. 90 (1995) 343
- Minoura, S., see Sato, S. 90 (1995) 29
- Mohamed, M.H., M.M. Abdillahi, N.M.
Abbas and A.B. Siddiqui, An XPS study
of the optimum loading of barium on
high-silica MFI zeolite 90 (1995) 409
- Molchanovskii, I.A., see Dmitruk, N.L. 90 (1995) 489
- Morishita, T., see Wang, F. 90 (1995) 123
- Nowicka, E., see Duś, R. 90 (1995) 277
- Nuzzo, R.G., see Jackson, S.T. 90 (1995) 195
- Oakey, P.R., see Russell, S.W. 90 (1995) 455
- Ogawa, K., see Wang, F. 90 (1995) 123
- Okahata, Y., see Piscevic, D. 90 (1995) 425
- Orlando, S., see Teghil, R. 90 (1995) 505
- Paggel, J.J., see Keil, M. 90 (1995) 377
- Paloura, E.C., see Kennou, S. 90 (1995) 283
- Pancíř, J., see Pingo, M. 90 (1995) 373
- Papaioannou, G., see Thurzo, I. 90 (1995) 39
- Park, D., see Smith, G.C. 90 (1995) 357
- Persch, V., see Engelhard, H. 90 (1995) 89
- Pető, G., see Sundararajan, R. 90 (1995) 165
- Pincik, E., see Thurzo, I. 90 (1995) 39
- Pingo, M., J. Vošta, J. Pancíř and I.
Haslingerová, Topological study of
crack growth on iron crystal 90 (1995) 373
- Pirri, C., see Hong, S. 90 (1995) 65
- Piscevic, D., R. Lawall, M. Veith, M. Liley,
Y. Okahata and W. Knoll, Oligonu-
cleotide hybridization observed by sur-
face plasmon optical techniques 90 (1995) 425
- Pizzella, G., see Teghil, R. 90 (1995) 505
- Räisänen, J., see Ahlgren, T. 90 (1995) 419
- Rauhala, E., see Ahlgren, T. 90 (1995) 419
- Ravelet, S., see Easwarakhanthan, T. 90 (1995) 251
- Renard, P., see Easwarakhanthan, T. 90 (1995) 251
- Ringer, S.P., K. Hono and T. Sakurai, Erra-
tum to "Nucleation and growth of
θ' precipitation in Sn-modified Al-Cu
alloys: APFIM/TEM observations"
[Appl. Surf. Sci. 87/88 (1995) 223] 90 (1995) 107
- Robinson, B.J., see LaPierre, R.R. 90 (1995) 437
- Rochefort, A., see Debauge, Y. 90 (1995) 15
- Roy, D., see Lamontagne, B. 90 (1995) 447, 481
- Roy, J.A., see Zou, H. 90 (1995) 59
- Russell, S.W., J. Li, T.L. Alford, P.R. Oakey
and S.C. Shatas, Rapid thermal nitrida-
tion of thin chromium films 90 (1995) 455
- Saied, S.O., see Sullivan, J.L. 90 (1995) 309
- Sakurai, T., see Ringer, S.P. 90 (1995) 107
- Salaita, G.N., Determination of the spatial
distribution of trace elements in stain-
less steel by imaging microprobe sec-
ondary ion mass spectrometry 90 (1995) 465
- Salvi, A.M., J.E. Castle, J.F. Watts and E.
Desimoni, Peak fitting of the chromium
2p XPS spectrum 90 (1995) 333
- Santagata, A., see Teghil, R. 90 (1995) 505
- Sato, S., S. Minoura, T. Urisu and Y.
Takasu, IRAS and TDS study on the
photolytic decarbonylation of iron pen-
tacarbonyl adsorbed on a SiO₂ film with
a buried metal layer 90 (1995) 29
- Schaefer, J.A., see Engelhard, H. 90 (1995) 89
- Schedel-Niedrig, Th., see Keil, M. 90 (1995) 377
- Schlottig, F., J. Schreckenbach, D. Dietrich,
A. Hofmann and G. Marx, Conversion
film formation on titanium anodes in
acetonitrile at high voltages 90 (1995) 129
- Schneider, Y.-J., see Deldime, M. 90 (1995) 1
- Schreckenbach, J., see Schlottig, F. 90 (1995) 129
- Schultz, R.J., see Zou, H. 90 (1995) 59
- Seidman, D.N., see Van Bakel, G.P.E.M. 90 (1995) 95
- Semond, F., see Lamontagne, B. 90 (1995) 447
- Shatas, S.C., see Russell, S.W. 90 (1995) 455
- Siddiqui, A.B., see Mohamed, M.H. 90 (1995) 409
- Siimon, H., see Aarik, J. 90 (1995) 109
- Sirringhaus, H., see Kafader, U. 90 (1995) 297

- Sloboshanin, S., see Engelhard, H. 90 (1995) 89
- Smith, G.C., D. Park, K.J. Titchener, R.E. Davies and R.H. West, Surface studies of oil-seal degradation 90 (1995) 357
- Sobol, E.N., M.S. Kitai, S.M. Gol'berg and A.N. Zherikhin, Macro-particle ejection by laser ablation of high-temperature superconductors 90 (1995) 235
- Soh, H.G., see Lu, Y.F. 90 (1995) 217
- Song, Z.M., see Wu, J.D. 90 (1995) 81
- Sotobayashi, H., see Keil, M. 90 (1995) 377
- Sporken, R., see Lamontagne, B. 90 (1995) 481
- Sreemany, M. and T.B. Ghosh, Angle resolved XPS study of inhomogeneous specimens of polycrystalline silver covered with uniform graphite overlayers 90 (1995) 241
- Stepanova, M.G., see Hofmann, S. 90 (1995) 227
- Stietz, F., see Engelhard, H. 90 (1995) 89
- Sugahara, S., M. Kadoshima, T. Kitamura, S. Imai and M. Matsumura, Atomic hydrogen-assisted ALE of germanium 90 (1995) 349
- Sullivan, J.L., W. Yu and S.O. Saied, A study of the compositional changes in chemically etched, Ar ion bombarded and reactive ion etched GaAs(100) surfaces by means of ARXPS and LEISS 90 (1995) 309
- Sundararajan, R., G. Pető, E. Koltay and L. Guczi, Photoemission studies on Pt foil implanted by carbon atoms accelerated in a Van de Graaff generator: nature of the interaction between Pt and carbon 90 (1995) 165
- Suppiah, S., see Huang, M. 90 (1995) 393
- Szysko, W., Melting and diffusion under nanosecond laser pulse 90 (1995) 325
- Takasu, Y., see Sato, S. 90 (1995) 29
- Taranets, T.A., see Dmitruk, N.L. 90 (1995) 489
- Tate, T.J., see Taverner, A.E. 90 (1995) 383
- Taverner, A.E., A. Gulino, R.G. Egdell and T.J. Tate, A photoemission study of electron states in Sb-ion implanted TiO₂(110) 90 (1995) 383
- Teghil, R., A. Santagata, V. Marotta, S. Orlando, G. Pizzella, A. Giardini-Guidoni and A. Mele, Characterization of the plasma plume and of thin film epitaxially produced during laser ablation of SnSe 90 (1995) 505
- Thompson, D.A., see LaPierre, R.R. 90 (1995) 437
- Thurzo, I., E. Pincik, G. Papaioannou, P. Dimitrakakis and N. Arpatzanis, Experimental study of passivating ion-beam-induced distributed energy levels in n-GaAs by hydrogen species from boiling water 90 (1995) 39
- Tiong, K.K., see Mar, S.Y. 90 (1995) 497
- Titchener, K.J., see Smith, G.C. 90 (1995) 357
- Tontegode, A.Ya. and F.K. Yusifov, Super-efficient diffusion of cesium atoms into rhenium covered by a 2D graphite film 90 (1995) 185
- Tutov, E.A. and A.A. Baev, Charge transfer processes in a-WO₃/Si heterostructure during electro- and photochromism 90 (1995) 303
- Urisu, T., see Sato, S. 90 (1995) 29
- Väkeväinen, K., see Ahlgren, T. 90 (1995) 419
- Van Bakel, G.P.E.M., K. Hariharan and D.N. Seidman, On the structure and chemistry of Ni₃Al on an atomic scale via atom-probe field-ion microscopy 90 (1995) 95
- Van Kooten, W.E.J., J.P.C. Van Nispen, O.L.J. Gijzeman and J.W. Geus, The reactivity of O₂/H₂, O₂/CO and O₂/C₃H₆ gas mixtures on Cu(111) 90 (1995) 137
- Van Nispen, J.P.C., see Van Kooten, W.E.J. 90 (1995) 137
- Van Wijk, R., P.C. Görts, A.J.M. Mens, O.L.J. Gijzeman, F.H.P.M. Habraken and J.W. Geus, XPS/NRA investigations of particle size effects during the oxidation of Cu particles supported on oxidised Si(100) 90 (1995) 261
- Veith, M., see Piscevic, D. 90 (1995) 425
- Von Känel, H., see Kafader, U. 90 (1995) 297
- Vošta, J., see Pingo, M. 90 (1995) 373
- Wang, F., M. Badaye, K. Ogawa and T. Morishita, Recovery and recrystallization of SrTiO₃(100) surface characterized by ion channeling 90 (1995) 123
- Wang, P.W., S. Bater, L.P. Zhang, M. Ascherl and J.H. Craig, Jr., XPS investigation of electron beam effects on a trimethylsilane dosed Si(100) surface 90 (1995) 413
- Watts, J.F., see Salvi, A.M. 90 (1995) 333
- Wei, Y., see Yang, X.-M. 90 (1995) 175
- West, R.H., see Smith, G.C. 90 (1995) 357
- Wetzel, P., see Hong, S. 90 (1995) 65
- Wolfram, Z., see Duš, R. 90 (1995) 277
- Wu, C.Z., see Wu, J.D. 90 (1995) 81
- Wu, J.D., C.Z. Wu, Z.M. Song, L.H. Wu and F.M. Li, Synthesis of molybdenum nitride γ-Mo₂N by multipulse laser irradiation of molybdenum in nitrogen 90 (1995) 81
- Wu, L.H., see Wu, J.D. 90 (1995) 81
- Wu, N.J., see Zomorrodian, A. 90 (1995) 343
- Xiao, D., see Yang, X.-M. 90 (1995) 175
- Xiao, X.R., Y. Lin, Y. Yang, X.G. Chen and J.K. You, Scanned laser spot photocurrent response studies of surface modifications of CdSe thin film electrodes 90 (1995) 321

- | | | | |
|---|---------------|--|---------------|
| Yakubtsov, O.A., see Dmitruk, N.L. | 90 (1995) 489 | Yu, W., see Sullivan, J.L. | 90 (1995) 309 |
| Yan, P. and S.-Z. Yang, Pulse plasma beam deposition of cubic boron nitride films on GCr15 steel bearing substrate at room temperature | 90 (1995) 149 | Yusifov, F.K., see Tontegode, A.Ya. | 90 (1995) 185 |
| Yang, S.-Z., see Yan, P. | 90 (1995) 149 | Zhang, L.P., see Wang, P.W. | 90 (1995) 413 |
| Yang, X.-M., D. Xiao, Z.-H. Lu and Y. Wei, Structural investigation of Langmuir-Blodgett monolayers of L- α -dipalmitoylphosphatidylcholine by atomic force microscopy | 90 (1995) 175 | Zherikhin, A.N., see Sobol, E.N. | 90 (1995) 235 |
| Yang, Y., see Xiao, X.R. | 90 (1995) 321 | Zielasek, V., A. Büssenschütt and M. Henzler, Multiple losses in off-specular electron energy loss spectra of thin NaCl films individually resolved in energy and momentum | 90 (1995) 117 |
| Yokoyama, S., see Keil, M. | 90 (1995) 377 | Zomorrodian, A., A. Mesarwi, N.J. Wu and A. Ignatiev, XPS oxygen line broadening in lead zirconium titanate and related materials | 90 (1995) 343 |
| Yom, S.S., see Kim, T.W. | 90 (1995) 75 | Zou, H., G.M. Hood, R.J. Schultz and J.A. Roy, Thermal etching of α -Zr single-crystal surfaces | 90 (1995) 59 |
| Yoon, Y.S., see Kim, T.W. | 90 (1995) 75 | | |
| You, J.K., see Xiao, X.R. | 90 (1995) 321 | | |



ELSEVIER

Applied Surface Science 90 (1995) 527-539

applied
surface science

Subject index

Ablation

- Macro-particle ejection by laser ablation of high-temperature superconductors, E.N. Sobol, M.S. Kitai, S.M. Gol'berg and A.N. Zherikhin 90 (1995) 235
- Characterization of the plasma plume and of thin film epitaxially produced during laser ablation of SnSe, R. Teghil, A. Santagata, V. Marotta, S. Orlando, G. Pizzella, A. Giardini-Guidoni and A. Mele 90 (1995) 505

Alkali halides

- Multiple losses in off-specular electron energy loss spectra of thin NaCl films individually resolved in energy and momentum, V. Zielasek, A. Büssenschütt and M. Henzler 90 (1995) 117

Alkali metals

- Superefficient diffusion of cesium atoms into rhenium covered by a 2D graphite film, A.Ya. Tontegode and F.K. Yusifov 90 (1995) 185
- An XPS study of the optimum loading of barium on high-silica MFI zeolite, M.H. Mohamed, M.M. Abdillahi, N.M. Abbas and A.B. Siddiqui 90 (1995) 409
- SIMS investigation of the Si(111) oxidation promoted by potassium overlayers, B. Lamontagne, F. Semond, A. Adnot and D. Roy 90 (1995) 447

Alloys

- Synergistic alloying behaviour of Pd₅₀Cu₅₀ single crystals upon adsorption and co-adsorption of CO and NO, Y. Debauge, M. Abon, J.C. Bertolini, J. Massardier and A. Rochefort 90 (1995) 15
- Erratum to "Nucleation and growth of θ' precipitation in Sn-modified Al-Cu

alloys: APFIM/TEM observations"

[Appl. Surf. Sci. 87/88 (1995) 223],

S.P. Ringer, K. Hono and T. Sakurai

90 (1995) 107

Surface segregation and core-level shift of a

Pd-Rh alloy studied by XPS, J.A. Leiro,

M.H. Heinonen and I.G. Batirev

90 (1995) 515

Aluminium

- On the structure and chemistry of Ni₃Al on an atomic scale via atom-probe field-ion microscopy, G.P.E.M. Van Bakel, K. Hariharan and D.N. Seidman 90 (1995) 95
- Erratum to "Nucleation and growth of θ' precipitation in Sn-modified Al-Cu alloys: APFIM/TEM observations" [Appl. Surf. Sci. 87/88 (1995) 223], S.P. Ringer, K. Hono and T. Sakurai 90 (1995) 107

Annealing

- Rapid thermal nitridation of thin chromium films, S.W. Russell, J. Li, T.L. Alford, P.R. Oakey and S.C. Shatas 90 (1995) 455

Antimony

- Surface segregation of Sb in doped TiO₂ rutile, A. Gulino, G.G. Condorelli, I. Fragalà and R.G. Egdell 90 (1995) 289
- A photoemission study of electron states in Sb-ion implanted TiO₂(110), A.E. Taverner, A. Gulino, R.G. Egdell and T.J. Tate 90 (1995) 383

Atomic force microscopy

- Characterization of nickel films deposited by cold remote nitrogen plasma on acrylonitrile-butadiene-styrene copolymer, A. Brocherieux, O. Dessaux, P. Goudmand, L. Gengembre, J. Grimblot, M. Brunel and R. Lazzaroni 90 (1995) 47
- An investigation using atomic force microscopy and X-ray photoelectron spec-

- troscopy of the modification of the surface of mica with an argon RF-plasma discharge, N.M.D. Brown and Z.-H. Liu 90 (1995) 155
- Structural investigation of Langmuir-Blodgett monolayers of L- α -dipalmitoylphosphatidylcholine by atomic force microscopy, X.-M. Yang, D. Xiao, Z.-H. Lu and Y. Wei 90 (1995) 175
- AFM and XPS characterization of the Si(111) surface after thermal treatment, B. Lamontagne, D. Guay, D. Roy, R. Sporken and R. Caudano 90 (1995) 481
- Atomic probe analysis*
- On the structure and chemistry of Ni₃Al on an atomic scale via atom-probe field-ion microscopy, G.P.E.M. Van Bakel, K. Hariharan and D.N. Seidman 90 (1995) 95
- Auger electron spectroscopy*
- Synergistic alloying behaviour of Pd₅₀Cu₅₀ single crystals upon adsorption and co-adsorption of CO and NO, Y. Debauge, M. Abon, J.C. Bertolini, J. Massardier and A. Rochefort 90 (1995) 15
- Ferroelectric BaTiO₃ films with a high-magnitude dielectric constant grown on p-Si by low-pressure metalorganic chemical vapor deposition, T.W. Kim, Y.S. Yoon, S.S. Yom and C.O. Kim 90 (1995) 75
- Synthesis of molybdenum nitride γ -Mo₂N by multipulse laser irradiation of molybdenum in nitrogen, J.D. Wu, C.Z. Wu, Z.M. Song, L.H. Wu and F.M. Li 90 (1995) 81
- Pulse plasma beam deposition of cubic boron nitride films on GCr15 steel bearing substrate at room temperature, P. Yan and S.-Z. Yang 90 (1995) 149
- Determining hybridization differences for amorphous carbon from the XPS C 1s envelope, S.T. Jackson and R.G. Nuzzo 90 (1995) 195
- XPS/NRA investigations of particle size effects during the oxidation of Cu particles supported on oxidised Si(100), R. van Wijk, P.C. Görts, A.J.M. Mens, O.L.J. Gijzeman, F.H.P.M. Habraken and J.W. Geus 90 (1995) 261
- Morphology, atomic composition and photoelectric properties of the microrelief InP-electrolyte interface, N.L. Dmitruk, E.V. Basiuk, G.Ya. Kolbasov, O.A. Yakubtsov, I.A. Molchanovskii and T.A. Taranets 90 (1995) 489
- Barium*
- Ferroelectric BaTiO₃ films with a high-magnitude dielectric constant grown on p-Si by low-pressure metalorganic chemical vapor deposition, T.W. Kim, Y.S. Yoon, S.S. Yom and C.O. Kim 90 (1995) 75
- Boron nitride*
- Pulse plasma beam deposition of cubic boron nitride films on GCr15 steel bearing substrate at room temperature, P. Yan and S.-Z. Yang 90 (1995) 149
- Cadmium selenide*
- Scanned laser spot photocurrent response studies of surface modifications of CdSe thin film electrodes, X.R. Xiao, Y. Lin, Y. Yang, X.G. Chen and J.K. You 90 (1995) 321
- Carbon*
- Photoemission studies on Pt foil implanted by carbon atoms accelerated in a Van de Graaff generator: nature of the interaction between Pt and carbon, R. Sundarajan, G. Pető, E. Koltay and L. Guzzi 90 (1995) 165
- Determining hybridization differences for amorphous carbon from the XPS C 1s envelope, S.T. Jackson and R.G. Nuzzo 90 (1995) 195
- Surface studies of Cu/Cr/Ag impregnated microporous carbons, R.H. Bradley 90 (1995) 271
- Carbon dioxide*
- Surface interaction between H₂ and CO₂ over silicalite-supported platinum, M. Huang, S. Kaliaguine and S. Suppiah 90 (1995) 393
- Carbon monoxide*
- Synergistic alloying behaviour of Pd₅₀Cu₅₀ single crystals upon adsorption and co-adsorption of CO and NO, Y. Debauge, M. Abon, J.C. Bertolini, J. Massardier and A. Rochefort 90 (1995) 15
- The reactivity of O₂/H₂, O₂/CO and O₂/C₃H₆ gas mixtures on Cu(111), W.E.J. van Kooten, J.P.C. van Nispen, O.L.J. Gijzeman and J.W. Geus 90 (1995) 137

Chemical vapour deposition

- Erratum to "Characterization of adsorption in flow type atomic layer epitaxy reactor" [Appl. Surf. Sci. 81 (1994) 281], J. Aarik and H. Siimon

90 (1995) 109

Chromium

- Surface studies of Cu/Cr/Ag impregnated microporous carbons, R.H. Bradley
Peak fitting of the chromium 2p XPS spectrum, A.M. Salvi, J.E. Castle, J.F. Watts and E. Desimoni
Rapid thermal nitridation of thin chromium films, S.W. Russell, J. Li, T.L. Alford, P.R. Oakey and S.C. Shatas

90 (1995) 271

90 (1995) 333

90 (1995) 455

Computer simulations

- Preferential sputtering of argon ion bombarded Ni₃Al and TaSi₂, S. Hofmann and M.G. Stepanova

90 (1995) 227

Copper

- Synergistic alloying behaviour of Pd₅₀Cu₅₀ single crystals upon adsorption and co-adsorption of CO and NO, Y. Debaugé, M. Abon, J.C. Bertolini, J. Massardier and A. Rochefort
Erratum to "Nucleation and growth of θ' precipitation in Sn-modified Al-Cu alloys: APFIM/TEM observations" [Appl. Surf. Sci. 87/88 (1995) 223], S.P. Ringer, K. Hono and T. Sakurai
The reactivity of O₂/H₂, O₂/CO and O₂/C₃H₆ gas mixtures on Cu(111), W.E.J. van Kooten, J.P.C. van Nispen, O.L.J. Gijzeman and J.W. Geus
Surface studies of Cu/Cr/Ag impregnated microporous carbons, R.H. Bradley
Atomic hydrogen adsorption on sintered thin copper films, R. Duś, E. Nowicka, W. Lisowski and Z. Wolfram
XPS/NRA investigations of particle size effects during the oxidation of Cu particles supported on oxidised Si(100), R. van Wijk, P.C. Görts, A.J.M. Mens, O.L.J. Gijzeman, F.H.P.M. Habraken and J.W. Geus

90 (1995) 15

90 (1995) 107

90 (1995) 137

90 (1995) 271

90 (1995) 277

90 (1995) 261

Depth profiling

- Surface segregation of Sb in doped TiO₂ rutile, A. Gulino, G.G. Condorelli, I. Fragalà and R.G. Egdell

90 (1995) 289

Electrical properties

- Experimental study of passivating ion-beam-induced distributed energy levels in n-GaAs by hydrogen species from boiling water, I. Thurzo, E. Pincik, G. Papaioannou, P. Dimitrakis and N. Arpatzanis
Atomic hydrogen adsorption on sintered thin copper films, R. Duś, E. Nowicka, W. Lisowski and Z. Wolfram
Charge transfer processes in a-WO₃/Si heterostructure during electro- and photochromism, E.A. Tutov and A.A. Baev
Scanned laser spot photocurrent response studies of surface modifications of CdSe thin film electrodes, X.R. Xiao, Y. Lin, Y. Yang, X.G. Chen and J.K. You
Morphology, atomic composition and photoelectric properties of the microrelief InP-electrolyte interface, N.L. Dmitruk, E.V. Basiuk, G.Ya. Kolbasov, O.A. Yakubtsov, I.A. Molchanovskii and T.A. Taranets
Characterization of the plasma plume and of thin film epitaxially produced during laser ablation of SnSe, R. Teghil, A. Santagata, V. Marotta, S. Orlando, G. Pizzella, A. Giardini-Guidoni and A. Mele

90 (1995) 39

90 (1995) 277

90 (1995) 303

90 (1995) 321

90 (1995) 489

90 (1995) 505

Electron diffraction

- Medium energy electron diffraction and X-ray photoelectron diffraction study of pseudomorphic Fe silicides grown on Si(111). Evidence of Fe vacancy formation, S. Hong, C. Pirri, P. Wetzels, D. Bolmont and G. Gewinner
Conversion film formation on titanium anodes in acetonitrile at high voltages, F. Schlottig, J. Schreckenbach, D. Dietrich, A. Hofmann and G. Marx
In situ DC-plasma cleaning of silicon surfaces, U. Kafader, H. Siringhaus and H. von Känel

90 (1995) 65

90 (1995) 129

90 (1995) 297

Electron energy loss spectroscopy

- Multiple losses in off-specular electron energy loss spectra of thin NaCl films individually resolved in energy and momentum, V. Zielasek, A. Büssenschütt and M. Henzler

90 (1995) 117

Electron microscopy

- Characterization of nickel films deposited by cold remote nitrogen plasma on acrylonitrile-butadiene-styrene copolymer, A. Brocherieux, O. Dessaux, P. Goudmand, L. Gengembre, J. Grimblot, M. Brunel and R. Lazzaroni 90 (1995) 47
- Thermal etching of α -Zr single-crystal surfaces, H. Zou, G.M. Hood, R.J. Schultz and J.A. Roy 90 (1995) 59
- Ferroelectric BaTiO₃ films with a high-magnitude dielectric constant grown on p-Si by low-pressure metalorganic chemical vapor deposition, T.W. Kim, Y.S. Yoon, S.S. Yom and C.O. Kim 90 (1995) 75
- Synthesis of molybdenum nitride γ -Mo₂N by multipulse laser irradiation of molybdenum in nitrogen, J.D. Wu, C.Z. Wu, Z.M. Song, L.H. Wu and F.M. Li 90 (1995) 81
- Erratum to "Nucleation and growth of θ' precipitation in Sn-modified Al-Cu alloys: APFIM/TEM observations" [Appl. Surf. Sci. 87/88 (1995) 223], S.P. Ringer, K. Hono and T. Sakurai 90 (1995) 107
- Pulse plasma beam deposition of cubic boron nitride films on GCr15 steel bearing substrate at room temperature, P. Yan and S.-Z. Yang 90 (1995) 149
- Surface studies of oil-seal degradation, G.C. Smith, D. Park, K.J. Titchener, R.E. Davies and R.H. West 90 (1995) 357
- Morphology, atomic composition and photoelectric properties of the microrelief InP-electrolyte interface, N.L. Dmitruk, E.V. Basiuk, G.Ya. Kolbasov, O.A. Yakubtsov, I.A. Molchanovskii and T.A. Taranets 90 (1995) 489
- Characterization of the plasma plume and of thin film epitaxially produced during laser ablation of SnSe, R. Teghil, A. Santagata, V. Marotta, S. Orlando, G. Pizzella, A. Giardini-Guidoni and A. Mele 90 (1995) 505

Ellipsometry

- The reactivity of O₂/H₂, O₂/CO and O₂/C₃H₆ gas mixtures on Cu(111), W.E.J. van Kooten, J.P.C. van Nispen, O.L.J. Gijzeman and J.W. Geus 90 (1995) 137
- An ellipsometric procedure for the characterization of very thin surface films on absorbing substrates, T. Easwarakhanthan, S. Ravelet and P. Renard 90 (1995) 251

Epitaxy

- Erratum to "Characterization of adsorption in flow type atomic layer epitaxy reactor" [Appl. Surf. Sci. 81 (1994) 281], J. Aarik and H. Siimon 90 (1995) 109
- Multiple losses in off-specular electron energy loss spectra of thin NaCl films individually resolved in energy and momentum, V. Zielasek, A. Büssenschütt and M. Henzler 90 (1995) 117
- Atomic hydrogen-assisted ALE of germanium, S. Sugahara, M. Kadoshima, T. Kitamura, S. Imai and M. Matsumura 90 (1995) 349
- Lateral composition modulation in InGaAsP deposited by gas source molecular beam epitaxy on (100)- and (*h*11)-oriented InP substrates, R.R. LaPierre, B.J. Robinson and D.A. Thompson 90 (1995) 437
- Characterization of the plasma plume and of thin film epitaxially produced during laser ablation of SnSe, R. Teghil, A. Santagata, V. Marotta, S. Orlando, G. Pizzella, A. Giardini-Guidoni and A. Mele 90 (1995) 505

Etching

- Experimental study of passivating ion-beam-induced distributed energy levels in n-GaAs by hydrogen species from boiling water, I. Thurzo, E. Pincik, G. Papaioannou, P. Dimitrakakis and N. Arpatzanis 90 (1995) 39
- Thermal etching of α -Zr single-crystal surfaces, H. Zou, G.M. Hood, R.J. Schultz and J.A. Roy 90 (1995) 59
- A study of the compositional changes in chemically etched, Ar ion bombarded and reactive ion etched GaAs(100) surfaces by means of ARXPS and LEISS, J.L. Sullivan, W. Yu and S.O. Saied 90 (1995) 309

Evaporation

- The influence of the substrate material on the growth of V₂O₅ flash-evaporated films, C. Julien, J.P. Guesdon, A. Gorenstein, A. Khelfa and I. Ivanov 90 (1995) 389

Field ion microscopy

- On the structure and chemistry of Ni₃Al on an atomic scale via atom-probe field-ion microscopy, G.P.E.M. Van Bakel, K. Hariharan and D.N. Seidman 90 (1995) 95
- Erratum to "Nucleation and growth of θ' precipitation in Sn-modified Al-Cu

alloys: APFIM/TEM observations''
[Appl. Surf. Sci. 87/88 (1995) 223],
S.P. Ringer, K. Hono and T. Sakurai

90 (1995) 107

Gallium arsenide

Experimental study of passivating ion-beam-induced distributed energy levels in n-GaAs by hydrogen species from boiling water, I. Thurzo, E. Pincik, G. Papaioannou, P. Dimitrakakis and N. Arpatzanis

90 (1995) 39

A study of the compositional changes in chemically etched, Ar ion bombarded and reactive ion etched GaAs(100) surfaces by means of ARXPS and LEISS, J.L. Sullivan, W. Yu and S.O. Saied

90 (1995) 309

Lateral composition modulation in InGaAsP deposited by gas source molecular beam epitaxy on (100)- and (*h*11)-oriented InP substrates, R.R. LaPierre, B.J. Robinson and D.A. Thompson

90 (1995) 437

Germanium

Multiple losses in off-specular electron energy loss spectra of thin NaCl films individually resolved in energy and momentum, V. Zielasek, A. Büssenschütt and M. Henzler

90 (1995) 117

Atomic hydrogen-assisted ALE of germanium, S. Sugahara, M. Kadoshima, T. Kitamura, S. Imai and M. Matsumura

90 (1995) 349

Graphite

Superefficient diffusion of cesium atoms into rhenium covered by a 2D graphite film, A.Ya. Tontegode and F.K. Yusifov

90 (1995) 185

Angle resolved XPS study of inhomogeneous specimens of polycrystalline silver covered with uniform graphite overlayers, M. Sreemany and T.B. Ghosh

90 (1995) 241

Halogenides

Silicon surface cleaning using XeF₂ gas treatment, V.S. Aliev, M.R. Baklanov and V.I. Bukhtiyarov

90 (1995) 191

Hydrocarbons

The reactivity of O₂/H₂, O₂/CO and O₂/C₃H₆ gas mixtures on Cu(111), W.E.J. van Kooten, J.P.C. van Nispen, O.L.J. Gijzeman and J.W. Geus

90 (1995) 137

Hydrogen

Experimental study of passivating ion-beam-induced distributed energy levels in n-GaAs by hydrogen species from boiling water, I. Thurzo, E. Pincik, G. Papaioannou, P. Dimitrakakis and N. Arpatzanis

90 (1995) 39

Hydrogen adsorption induced phase transitions on Si(100)-c(8 × 8): temperature dependence studied by LEED, X. Hu and Z. Lin

90 (1995) 111

The reactivity of O₂/H₂, O₂/CO and O₂/C₃H₆ gas mixtures on Cu(111), W.E.J. van Kooten, J.P.C. van Nispen, O.L.J. Gijzeman and J.W. Geus

90 (1995) 137

Atomic hydrogen adsorption on sintered thin copper films, R. Duś, E. Nowicka, W. Lisowski and Z. Wolfram

90 (1995) 277

Atomic hydrogen-assisted ALE of germanium, S. Sugahara, M. Kadoshima, T. Kitamura, S. Imai and M. Matsumura

90 (1995) 349

Surface interaction between H₂ and CO₂ over silicalite-supported platinum, M. Huang, S. Kaliaguine and S. Suppiah

90 (1995) 393

Indium phosphide

Interfacial reaction of Ag with the InP(100)4 × 2 surface – a photoemission study, H. Engelhard, F. Stietz, S. Sloboshanin, V. Persch, Th. Allinger, J.A. Schaefer and A. Goldmann

90 (1995) 89

Lateral composition modulation in InGaAsP deposited by gas source molecular beam epitaxy on (100)- and (*h*11)-oriented InP substrates, R.R. LaPierre, B.J. Robinson and D.A. Thompson

90 (1995) 437

Morphology, atomic composition and photoelectric properties of the microrelief InP–electrolyte interface, N.L. Dmitruk, E.V. Basiuk, G.Ya. Kolbasov, O.A. Yakubtsov, I.A. Molchanovskii and T.A. Taranets

90 (1995) 489

Infrared spectroscopy

IRAS and TDS study on the photolytic decarbonylation of iron pentacarbonyl adsorbed on a SiO₂ film with a buried metal layer, S. Sato, S. Minoura, T. Urisu and Y. Takasu

90 (1995) 29

Pulse plasma beam deposition of cubic boron nitride films on GCr15 steel bearing substrate at room temperature, P. Yan and S.-Z. Yang

90 (1995) 149

A quantitative time-of-flight secondary ion mass spectrometry study of ion forma-

- tion mechanisms using acid-base alternating Langmuir-Blodgett films, J.-X. Li, J.A. Gardella, Jr. and P.J. McKeown 90 (1995) 205
- Surface interaction between H_2 and CO_2 over silicalite-supported platinum, M. Huang, S. Kaliaguine and S. Suppiah 90 (1995) 393

Ion bombardment

- Preferential sputtering of argon ion bombarded Ni_3Al and $TaSi_2$, S. Hofmann and M.G. Stepanova 90 (1995) 227
- A study of the compositional changes in chemically etched, Ar ion bombarded and reactive ion etched GaAs(100) surfaces by means of ARXPS and LEISS, J.L. Sullivan, W. Yu and S.O. Saied 90 (1995) 309

Ion implantation

- A photoemission study of electron states in Sb-ion implanted $TiO_2(110)$, A.E. Taverner, A. Gulino, R.G. Egdell and T.J. Tate 90 (1995) 383
- Range profiles of 6–10 MeV ^{15}N ions implanted in silicon, T. Ahlgren, K. Väkeväinen, J. Räisänen, E. Rauhala and J. Keinonen 90 (1995) 419

Ion scattering

- Synergistic alloying behaviour of $Pd_{50}Cu_{50}$ single crystals upon adsorption and co-adsorption of CO and NO, Y. Debaugé, M. Abon, J.C. Bertolini, J. Massardier and A. Rochefort 90 (1995) 15
- Recovery and recrystallization of $SrTiO_3(100)$ surface characterized by ion channeling, F. Wang, M. Badaye, K. Ogawa and T. Morishita 90 (1995) 123
- XPS/NRA investigations of particle size effects during the oxidation of Cu particles supported on oxidised Si(100), R. van Wijk, P.C. Görts, A.J.M. Mens, O.L.J. Gijzeman, F.H.P.M. Habraken and J.W. Geus 90 (1995) 261
- A study of the compositional changes in chemically etched, Ar ion bombarded and reactive ion etched GaAs(100) surfaces by means of ARXPS and LEISS, J.L. Sullivan, W. Yu and S.O. Saied 90 (1995) 309

Iron

- Medium energy electron diffraction and X-ray photoelectron diffraction study of

- pseudomorphic Fe silicides grown on Si(111). Evidence of Fe vacancy formation, S. Hong, C. Pirri, P. Wetzel, D. Bolmont and G. Gewinner 90 (1995) 65
- Topological study of crack growth on iron crystal, M. Pingo, J. Vošta, J. Pancíř and I. Haslingerová 90 (1995) 373

Langmuir-Blodgett structures

- Structural investigation of Langmuir-Blodgett monolayers of L- α -dipalmitoylphosphatidylcholine by atomic force microscopy, X.-M. Yang, D. Xiao, Z.-H. Lu and Y. Wei 90 (1995) 175
- A quantitative time-of-flight secondary ion mass spectrometry study of ion formation mechanisms using acid-base alternating Langmuir-Blodgett films, J.-X. Li, J.A. Gardella, Jr. and P.J. McKeown 90 (1995) 205

Laser processing

- Synthesis of molybdenum nitride $\gamma-Mo_2N$ by multipulse laser irradiation of molybdenum in nitrogen, J.D. Wu, C.Z. Wu, Z.M. Song, L.H. Wu and F.M. Li 90 (1995) 81
- Laser-induced temperature rise in Gaussian-shaped holes, Y.F. Lu, T.E. Loh, H.G. Soh and T.S. Low 90 (1995) 217
- Melting and diffusion under nanosecond laser pulse, W. Szyszko 90 (1995) 325

Lead

- XPS oxygen line broadening in lead zirconium titanate and related materials, A. Zomorrodian, A. Mesarwi, N.J. Wu and A. Ignatiev 90 (1995) 343

Low energy electron diffraction

- Synergistic alloying behaviour of $Pd_{50}Cu_{50}$ single crystals upon adsorption and co-adsorption of CO and NO, Y. Debaugé, M. Abon, J.C. Bertolini, J. Massardier and A. Rochefort 90 (1995) 15
- Ferroelectric $BaTiO_3$ films with a high-magnitude dielectric constant grown on p-Si by low-pressure metalorganic chemical vapor deposition, T.W. Kim, Y.S. Yoon, S.S. Yom and C.O. Kim 90 (1995) 75
- Hydrogen adsorption induced phase transitions on Si(100)-c(8×8): temperature dependence studied by LEED, X. Hu and Z. Lin 90 (1995) 111

Luminescence

- Lateral composition modulation in InGaAsP deposited by gas source molecular beam epitaxy on (100)- and (*h*11)-oriented InP substrates, R.R. LaPierre, B.J. Robinson and D.A. Thompson 90 (1995) 437

Mass spectroscopy

- The reactivity of O₂/H₂, O₂/CO and O₂/C₃H₆ gas mixtures on Cu(111), W.E.J. van Kooten, J.P.C. van Nispen, O.L.J. Gijzeman and J.W. Geus 90 (1995) 137
- Superefficient diffusion of cesium atoms into rhenium covered by a 2D graphite film, A.Ya. Tontegode and F.K. Yusifov 90 (1995) 185
- Atomic hydrogen adsorption on sintered thin copper films, R. Duś, E. Nowicka, W. Lisowski and Z. Wolfram 90 (1995) 277
- Characterization of the plasma plume and of thin film epitaxially produced during laser ablation of SnSe, R. Teghil, A. Santagata, V. Marotta, S. Orlando, G. Pizzella, A. Giardini-Guidoni and A. Mele 90 (1995) 505

Mica

- An investigation using atomic force microscopy and X-ray photoelectron spectroscopy of the modification of the surface of mica with an argon RF-plasma discharge, N.M.D. Brown and Z.-H. Liu 90 (1995) 155

Molybdenum

- Synthesis of molybdenum nitride γ -Mo₂N by multipulse laser irradiation of molybdenum in nitrogen, J.D. Wu, C.Z. Wu, Z.M. Song, L.H. Wu and F.M. Li 90 (1995) 81

Nickel

- Characterization of nickel films deposited by cold remote nitrogen plasma on acrylonitrile-butadiene-styrene copolymer, A. Brocherieux, O. Dessaux, P. Goudmand, L. Gengembre, J. Grimblot, M. Brunel and R. Lazzaroni 90 (1995) 47
- On the structure and chemistry of Ni₃Al on an atomic scale via atom-probe field-ion microscopy, G.P.E.M. Van Bakel, K. Hariharan and D.N. Seidman 90 (1995) 95

Nitric oxide

- Synergistic alloying behaviour of Pd₅₀Cu₅₀ single crystals upon adsorption and co-adsorption of CO and NO, Y. Debaugé, M. Abon, J.C. Bertolini, J. Massardier and A. Rochefort 90 (1995) 15

Nitrides

- Synthesis of molybdenum nitride γ -Mo₂N by multipulse laser irradiation of molybdenum in nitrogen, J.D. Wu, C.Z. Wu, Z.M. Song, L.H. Wu and F.M. Li 90 (1995) 81
- Rapid thermal nitridation of thin chromium films, S.W. Russell, J. Li, T.L. Alford, P.R. Oakey and S.C. Shatas 90 (1995) 455

Nitrogen

- Range profiles of 6–10 MeV ¹⁵N ions implanted in silicon, T. Ahlgren, K. Väkeväinen, J. Räisänen, E. Rauhala and J. Keinonen 90 (1995) 419

Nuclear reaction analysis

- XPS/NRA investigations of particle size effects during the oxidation of Cu particles supported on oxidised Si(100), R. van Wijk, P.C. Görts, A.J.M. Mens, O.L.J. Gijzeman, F.H.P.M. Habraken and J.W. Geus 90 (1995) 261

Optical properties

- Oligonucleotide hybridization observed by surface plasmon optical techniques, D. Piscevic, R. Lawall, M. Veith, M. Liley, Y. Okahata and W. Knoll 90 (1995) 425

Organic substances

- Structural investigation of Langmuir-Blodgett monolayers of L- α -dipalmitoylphosphatidylcholine by atomic force microscopy, X.-M. Yang, D. Xiao, Z.-H. Lu and Y. Wei 90 (1995) 175
- XPS investigation of electron beam effects on a trimethylsilane dosed Si(100) surface, P.W. Wang, S. Bäter, L.P. Zhang, M. Ascherl and J.H. Craig, Jr. 90 (1995) 413

Organometallic vapour deposition

- Characterization of nickel films deposited by cold remote nitrogen plasma on acrylonitrile-butadiene-styrene copolymer, A. Brocherieux, O. Dessaux, P. Goudmand, L. Gengembre, J. Grimblot, M. Brunel and R. Lazzaroni 90 (1995) 47
- Ferroelectric BaTiO₃ films with a high-magnitude dielectric constant grown on p-Si by low-pressure metalorganic chemical vapor deposition, T.W. Kim, Y.S. Yoon, S.S. Yom and C.O. Kim 90 (1995) 75

Oxides

- Ferroelectric BaTiO₃ films with a high-magnitude dielectric constant grown on p-Si by low-pressure metalorganic chemical vapor deposition, T.W. Kim, Y.S. Yoon, S.S. Yom and C.O. Kim 90 (1995) 75
- Recovery and recrystallization of SrTiO₃(100) surface characterized by ion channeling, F. Wang, M. Badaye, K. Ogawa and T. Morishita 90 (1995) 123
- XPS/NRA investigations of particle size effects during the oxidation of Cu particles supported on oxidised Si(100), R. van Wijk, P.C. Görts, A.J.M. Mens, O.L.J. Gijzeman, F.H.P.M. Habraken and J.W. Geus 90 (1995) 261
- SIMS investigation of the Si(111) oxidation promoted by potassium overlayers, B. Lamontagne, F. Semond, A. Adnot and D. Roy 90 (1995) 447
- Characterization of RuO₂ thin films by Raman spectroscopy, S.Y. Mar, C.S. Chen, Y.S. Huang and K.K. Tiong 90 (1995) 497

Oxygen

- The reactivity of O₂/H₂, O₂/CO and O₂/C₃H₆ gas mixtures on Cu(111), W.E.J. van Kooten, J.P.C. van Nispen, O.L.J. Gijzeman and J.W. Geus 90 (1995) 137
- XPS oxygen line broadening in lead zirconium titanate and related materials, A. Zomorrodian, A. Mesarwi, N.J. Wu and A. Ignatiev 90 (1995) 343

Palladium

- Synergistic alloying behaviour of Pd₅₀Cu₅₀ single crystals upon adsorption and co-adsorption of CO and NO, Y. Debauge, M. Abon, J.C. Bertolini, J. Massardier and A. Rochefort 90 (1995) 15

- Surface segregation and core-level shift of a Pd-Rh alloy studied by XPS, J.A. Leiro, M.H. Heinonen and I.G. Batirev 90 (1995) 515

Phase transitions

- Hydrogen adsorption induced phase transitions on Si(100)-c(8 × 8): temperature dependence studied by LEED, X. Hu and Z. Lin 90 (1995) 111

Photochemistry

- IRAS and TDS study on the photolytic decarbonylation of iron pentacarbonyl adsorbed on a SiO₂ film with a buried metal layer, S. Sato, S. Minoura, T. Urisu and Y. Takasu 90 (1995) 29

Photoelectron spectroscopy

- Reactivity assay of surface carboxyl chain-ends of poly(ethylene terephthalate) (PET) film and track-etched microporous membranes using fluorine labelled- and/or ³H-labelled derivatization reagents: tandem analysis by X-ray photoelectron spectroscopy (XPS) and liquid scintillation counting (LSC), M. Deldime, J.-L. Dewez, Y.-J. Schneider and J. Marchand-Brynaert 90 (1995) 1
- Characterization of nickel films deposited by cold remote nitrogen plasma on acrylonitrile-butadiene-styrene copolymer, A. Brocherieux, O. Dessaux, P. Goudmand, L. Gengembre, J. Grimblot, M. Brunel and R. Lazzaroni 90 (1995) 47
- Medium energy electron diffraction and X-ray photoelectron diffraction study of pseudomorphic Fe silicides grown on Si(111). Evidence of Fe vacancy formation, S. Hong, C. Pirri, P. Wetzel, D. Bolmont and G. Gewinner 90 (1995) 65
- Interfacial reaction of Ag with the InP(100)4 × 2 surface – a photoemission study, H. Engelhard, F. Stietz, S. Sloboshanin, V. Persch, Th. Allinger, J.A. Schaefer and A. Goldmann 90 (1995) 89
- Conversion film formation on titanium anodes in acetonitrile at high voltages, F. Schlottig, J. Schreckenbach, D. Dietrich, A. Hofmann and G. Marx 90 (1995) 129
- Pulse plasma beam deposition of cubic boron nitride films on GCr15 steel bearing substrate at room temperature, P. Yan and S.-Z. Yang 90 (1995) 149
- An investigation using atomic force microscopy and X-ray photoelectron spec-

- troscopy of the modification of the surface of mica with an argon RF-plasma discharge, N.M.D. Brown and Z.-H. Liu 90 (1995) 155
- Photoemission studies on Pt foil implanted by carbon atoms accelerated in a Van de Graaff generator: nature of the interaction between Pt and carbon, R. Sundararajan, G. Pető, E. Koltay and L. Guzzi 90 (1995) 165
- Determining hybridization differences for amorphous carbon from the XPS C 1s envelope, S.T. Jackson and R.G. Nuzzo 90 (1995) 195
- Angle resolved XPS study of inhomogeneous specimens of polycrystalline silver covered with uniform graphite overlayers, M. Sreemany and T.B. Ghosh 90 (1995) 241
- XPS/NRA investigations of particle size effects during the oxidation of Cu particles supported on oxidised Si(100), R. van Wijk, P.C. Görts, A.J.M. Mens, O.L.J. Gijzeman, F.H.P.M. Habraken and J.W. Geus 90 (1995) 261
- Surface studies of Cu/Cr/Ag impregnated microporous carbons, R.H. Bradley 90 (1995) 271
- Characterization of ex-situ hydrogenated amorphous SiC thin films by X-ray photoelectron spectroscopy, S. Kennou, S. Ladas, E.C. Paloura and J.A. Kalomiros 90 (1995) 283
- Surface segregation of Sb in doped TiO₂ rutile, A. Gulino, G.G. Condorelli, I. Fragalà and R.G. Egdell 90 (1995) 289
- In situ DC-plasma cleaning of silicon surfaces, U. Kafader, H. Sirringhaus and H. von Känel 90 (1995) 297
- A study of the compositional changes in chemically etched, Ar ion bombarded and reactive ion etched GaAs(100) surfaces by means of ARXPS and LEISS, J.L. Sullivan, W. Yu and S.O. Saied 90 (1995) 309
- Peak fitting of the chromium 2p XPS spectrum, A.M. Salvi, J.E. Castle, J.F. Watts and E. Desimoni 90 (1995) 333
- XPS oxygen line broadening in lead zirconium titanate and related materials, A. Zomorrodian, A. Mesarwi, N.J. Wu and A. Ignatiev 90 (1995) 343
- Surface studies of oil-seal degradation, G.C. Smith, D. Park, K.J. Titchener, R.E. Davies and R.H. West 90 (1995) 357
- The structure of PMDA-PDA polyimide monolayers adsorbed on gold surfaces, M. Keil, J.J. Paggel, Th. Schedel-Niedrig, S. Yokoyama, H. Sotobayashi and A.M. Bradshaw 90 (1995) 377
- A photoemission study of electron states in Sb-ion implanted TiO₂(110), A.E. Taverner, A. Gulino, R.G. Egdell and T.J. Tate 90 (1995) 383
- An XPS study of the optimum loading of barium on high-silica MFI zeolite, M.H. Mohamed, M.M. Abdillahi, N.M. Abbas and A.B. Siddiqui 90 (1995) 409
- XPS investigation of electron beam effects on a trimethylsilane dosed Si(100) surface, P.W. Wang, S. Bater, L.P. Zhang, M. Ascherl and J.H. Craig, Jr. 90 (1995) 413
- AFM and XPS characterization of the Si(111) surface after thermal treatment, B. Lamontagne, D. Guay, D. Roy, R. Sporken and R. Caudano 90 (1995) 481
- Surface segregation and core-level shift of a Pd-Rh alloy studied by XPS, J.A. Leiro, M.H. Heinonen and I.G. Batirev 90 (1995) 515
- ### Photoemission
- Photoemission studies on Pt foil implanted by carbon atoms accelerated in a Van de Graaff generator: nature of the interaction between Pt and carbon, R. Sundararajan, G. Pető, E. Koltay and L. Guzzi 90 (1995) 165
- ### Plasma processing
- Pulse plasma beam deposition of cubic boron nitride films on GCr15 steel bearing substrate at room temperature, P. Yan and S.-Z. Yang 90 (1995) 149
- An investigation using atomic force microscopy and X-ray photoelectron spectroscopy of the modification of the surface of mica with an argon RF-plasma discharge, N.M.D. Brown and Z.-H. Liu 90 (1995) 155
- In situ DC-plasma cleaning of silicon surfaces, U. Kafader, H. Sirringhaus and H. von Känel 90 (1995) 297
- ### Platinum
- Photoemission studies on Pt foil implanted by carbon atoms accelerated in a Van de Graaff generator: nature of the interaction between Pt and carbon, R. Sundararajan, G. Pető, E. Koltay and L. Guzzi 90 (1995) 165
- Surface interaction between H₂ and CO₂ over silicalite-supported platinum, M. Huang, S. Kaliaguine and S. Suppiah 90 (1995) 393
- ### Polymers
- Reactivity assay of surface carboxyl chain-ends of poly(ethylene terephthalate)

- (PET) film and track-etched microporous membranes using fluorine labelled- and/or ^3H -labelled derivatization reagents: tandem analysis by X-ray photoelectron spectroscopy (XPS) and liquid scintillation counting (LSC), M. Deldime, J.-L. Dewez, Y.-J. Schneider and J. Marchand-Brynaert 90 (1995) 1
- Characterization of nickel films deposited by cold remote nitrogen plasma on acrylonitrile-butadiene-styrene copolymer, A. Brocherieux, O. Dessaux, P. Goudmand, L. Gengembre, J. Grimblot, M. Brunel and R. Lazzaroni 90 (1995) 47
- Surface studies of oil-seal degradation, G.C. Smith, D. Park, K.J. Titchener, R.E. Davies and R.H. West 90 (1995) 357
- The structure of PMDA-PDA polyimide monolayers adsorbed on gold surfaces, M. Keil, J.J. Paggel, Th. Schedel-Niedrig, S. Yokoyama, H. Sotobayashi and A.M. Bradshaw 90 (1995) 377
- Radiation damage**
- Experimental study of passivating ion-beam-induced distributed energy levels in n-GaAs by hydrogen species from boiling water, I. Thurzo, E. Pincik, G. Papaioannou, P. Dimitrakis and N. Arpatzanis 90 (1995) 39
- Raman scattering**
- The influence of the substrate material on the growth of V_2O_5 flash-evaporated films, C. Julien, J.P. Guesdon, A. Gorenstein, A. Khelfa and I. Ivanov 90 (1995) 389
- Characterization of RuO_2 thin films by Raman spectroscopy, S.Y. Mar, C.S. Chen, Y.S. Huang and K.K. Tiong 90 (1995) 497
- Rhenium**
- Superefficient diffusion of cesium atoms into rhenium covered by a 2D graphite film, A.Ya. Tontegode and F.K. Yusifov 90 (1995) 185
- Rhodium**
- Surface segregation and core-level shift of a Pd-Rh alloy studied by XPS, J.A. Leiro, M.H. Heinonen and I.G. Batirev 90 (1995) 515
- Ruthenium**
- Characterization of RuO_2 thin films by Raman spectroscopy, S.Y. Mar, C.S. Chen, Y.S. Huang and K.K. Tiong 90 (1995) 497
- Scanning tunneling microscopy**
- In situ DC-plasma cleaning of silicon surfaces, U. Kafader, H. Sirringhaus and H. von Känel 90 (1995) 297
- The structure of PMDA-PDA polyimide monolayers adsorbed on gold surfaces, M. Keil, J.J. Paggel, Th. Schedel-Niedrig, S. Yokoyama, H. Sotobayashi and A.M. Bradshaw 90 (1995) 377
- Secondary ion mass spectrometry**
- A quantitative time-of-flight secondary ion mass spectrometry study of ion formation mechanisms using acid-base alternating Langmuir-Blodgett films, J.-X. Li, J.A. Gardella, Jr. and P.J. McKeown 90 (1995) 205
- In situ DC-plasma cleaning of silicon surfaces, U. Kafader, H. Sirringhaus and H. von Känel 90 (1995) 297
- SIMS investigation of the Si(111) oxidation promoted by potassium overlayers, B. Lamontagne, F. Semond, A. Adnot and D. Roy 90 (1995) 447
- Determination of the spatial distribution of trace elements in stainless steel by imaging microprobe secondary ion mass spectrometry, G.N. Salaita 90 (1995) 465
- Selenium**
- Characterization of the plasma plume and of thin film epitaxially produced during laser ablation of SnSe, R. Teghil, A. Santagata, V. Marotta, S. Orlando, G. Pizzella, A. Giardini-Guidoni and A. Mele 90 (1995) 505
- Silicides**
- Medium energy electron diffraction and X-ray photoelectron diffraction study of pseudomorphic Fe silicides grown on Si(111). Evidence of Fe vacancy formation, S. Hong, C. Pirri, P. Wetzel, D. Bolmont and G. Gewinner 90 (1995) 65

Silicon

- Medium energy electron diffraction and X-ray photoelectron diffraction study of pseudomorphic Fe silicides grown on Si(111). Evidence of Fe vacancy formation, S. Hong, C. Pirri, P. Wetzel, D. Bolmont and G. Gewinner 90 (1995) 65
- Hydrogen adsorption induced phase transitions on Si(100)-c(8 × 8): temperature dependence studied by LEED, X. Hu and Z. Lin 90 (1995) 111
- Silicon surface cleaning using XeF₂ gas treatment, V.S. Aliev, M.R. Baklanov and V.I. Bukhtiyarov 90 (1995) 191
- In situ DC-plasma cleaning of silicon surfaces, U. Kafader, H. Sirringhaus and H. von Känel 90 (1995) 297
- Charge transfer processes in a-WO₃/Si heterostructure during electro- and photochromism, E.A. Tutov and A.A. Baev 90 (1995) 303
- XPS investigation of electron beam effects on a trimethylsilane dosed Si(100) surface, P.W. Wang, S. Bater, L.P. Zhang, M. Ascherl and J.H. Craig, Jr. 90 (1995) 413
- Range profiles of 6–10 MeV ¹⁵N ions implanted in silicon, T. Ahlgren, K. Väkeväinen, J. Räisänen, E. Rauhala and J. Keinonen 90 (1995) 419
- SIMS investigation of the Si(111) oxidation promoted by potassium overlayers, B. Lamontagne, F. Semond, A. Adnot and D. Roy 90 (1995) 447
- AFM and XPS characterization of the Si(111) surface after thermal treatment, B. Lamontagne, D. Guay, D. Roy, R. Sporken and R. Caudano 90 (1995) 481

Silicon carbide

- Characterization of ex-situ hydrogenated amorphous SiC thin films by X-ray photoelectron spectroscopy, S. Kennou, S. Ladas, E.C. Paloura and J.A. Kalomiros 90 (1995) 283

Silicon oxide

- IRAS and TDS study on the photolytic decarbonylation of iron pentacarbonyl adsorbed on a SiO₂ film with a buried metal layer, S. Sato, S. Minoura, T. Urisu and Y. Takasu 90 (1995) 29

Silver

- Interfacial reaction of Ag with the InP(100)4 × 2 surface – a photoemis-

- sion study, H. Engelhard, F. Stietz, S. Sloboshanin, V. Persch, Th. Allinger, J.A. Schaefer and A. Goldmann 90 (1995) 89
- Angle resolved XPS study of inhomogeneous specimens of polycrystalline silver covered with uniform graphite overlayers, M. Sreemany and T.B. Ghosh 90 (1995) 241
- Surface studies of Cu/Cr/Ag impregnated microporous carbons, R.H. Bradley 90 (1995) 271

Sputtering

- Preferential sputtering of argon ion bombarded Ni₃Al and TaSi₂, S. Hofmann and M.G. Stepanova 90 (1995) 227

Steel

- Determination of the spatial distribution of trace elements in stainless steel by imaging microprobe secondary ion mass spectrometry, G.N. Salaita 90 (1995) 465

Strontium

- Recovery and recrystallization of SrTiO₃-(100) surface characterized by ion channeling, F. Wang, M. Badaye, K. Ogawa and T. Morishita 90 (1995) 123

Superconductivity

- Macro-particle ejection by laser ablation of high-temperature superconductors, E.N. Sobol, M.S. Kitai, S.M. Gol'berg and A.N. Zherikhin 90 (1995) 235

Surface plasmons

- Oligonucleotide hybridization observed by surface plasmon optical techniques, D. Piscevic, R. Lawall, M. Veith, M. Liley, Y. Okahata and W. Knoll 90 (1995) 425

Surface segregation

- Surface segregation and core-level shift of a Pd–Rh alloy studied by XPS, J.A. Leiro, M.H. Heinonen and I.G. Batirev 90 (1995) 515

Surface structure

- Thermal etching of α -Zr single-crystal surfaces, H. Zou, G.M. Hood, R.J. Schultz and J.A. Roy 90 (1995) 59

Thermal desorption

- Synergistic alloying behaviour of Pd₅₀Cu₅₀ single crystals upon adsorption and co-adsorption of CO and NO, Y. Debauge, M. Abon, J.C. Bertolini, J. Massardier and A. Rochefort 90 (1995) 15
- IRAS and TDS study on the photolytic decarbonylation of iron pentacarbonyl adsorbed on a SiO₂ film with a buried metal layer, S. Sato, S. Minoura, T. Urisu and Y. Takasu 90 (1995) 29
- Superefficient diffusion of cesium atoms into rhenium covered by a 2D graphite film, A.Ya. Tontegode and F.K. Yusifov 90 (1995) 185
- Atomic hydrogen adsorption on sintered thin copper films, R. Duś, E. Nowicka, W. Lisowski and Z. Wolfram 90 (1995) 277
- In situ DC-plasma cleaning of silicon surfaces, U. Kafader, H. Sirringhaus and H. von Känel 90 (1995) 297

Thin films

- Characterization of nickel films deposited by cold remote nitrogen plasma on acrylonitrile-butadiene-styrene copolymer, A. Brocherieux, O. Dessaux, P. Goudmand, L. Gengembre, J. Grimblot, M. Brunel and R. Lazzaroni 90 (1995) 47
- Ferroelectric BaTiO₃ films with a high-magnitude dielectric constant grown on p-Si by low-pressure metalorganic chemical vapor deposition, T.W. Kim, Y.S. Yoon, S.S. Yom and C.O. Kim 90 (1995) 75
- Multiple losses in off-specular electron energy loss spectra of thin NaCl films individually resolved in energy and momentum, V. Zielasek, A. Büssenschütt and M. Henzler 90 (1995) 117
- Conversion film formation on titanium anodes in acetonitrile at high voltages, F. Schlottig, J. Schreckenbach, D. Dietrich, A. Hofmann and G. Marx 90 (1995) 129
- Pulse plasma beam deposition of cubic boron nitride films on GCr15 steel bearing substrate at room temperature, P. Yan and S.-Z. Yang 90 (1995) 149
- An ellipsometric procedure for the characterization of very thin surface films on absorbing substrates, T. Easwarakhanthan, S. Ravelet and P. Renard 90 (1995) 251
- Atomic hydrogen adsorption on sintered thin copper films, R. Duś, E. Nowicka, W. Lisowski and Z. Wolfram 90 (1995) 277
- Characterization of ex-situ hydrogenated amorphous SiC thin films by X-ray pho-

- toelectron spectroscopy, S. Kennou, S. Ladas, E.C. Paloura and J.A. Kalomiros 90 (1995) 283
- Scanned laser spot photocurrent response studies of surface modifications of CdSe thin film electrodes, X.R. Xiao, Y. Lin, Y. Yang, X.G. Chen and J.K. You 90 (1995) 321
- The influence of the substrate material on the growth of V₂O₅ flash-evaporated films, C. Julien, J.P. Guesdon, A. Gorenstein, A. Khelifa and I. Ivanov 90 (1995) 389
- Rapid thermal nitridation of thin chromium films, S.W. Russell, J. Li, T.L. Alford, P.R. Oakey and S.C. Shatas 90 (1995) 455
- Characterization of RuO₂ thin films by Raman spectroscopy, S.Y. Mar, C.S. Chen, Y.S. Huang and K.K. Tiong 90 (1995) 497
- Characterization of the plasma plume and of thin film epitaxially produced during laser ablation of SnSe, R. Teghil, A. Santagata, V. Marotta, S. Orlando, G. Pizzella, A. Giardini-Guidoni and A. Mele 90 (1995) 505

Time of flight techniques

- A quantitative time-of-flight secondary ion mass spectrometry study of ion formation mechanisms using acid-base alternating Langmuir-Blodgett films, J.-X. Li, J.A. Gardella, Jr. and P.J. McKeown 90 (1995) 205

Tin

- Characterization of the plasma plume and of thin film epitaxially produced during laser ablation of SnSe, R. Teghil, A. Santagata, V. Marotta, S. Orlando, G. Pizzella, A. Giardini-Guidoni and A. Mele 90 (1995) 505
- Erratum to "Nucleation and growth of θ' precipitation in Sn-modified Al-Cu alloys: APFIM/TEM observations" [Appl. Surf. Sci. 87/88 (1995) 223], S.P. Ringer, K. Hono and T. Sakurai 90 (1995) 107

Titanium

- Ferroelectric BaTiO₃ films with a high-magnitude dielectric constant grown on p-Si by low-pressure metalorganic chemical vapor deposition, T.W. Kim, Y.S. Yoon, S.S. Yom and C.O. Kim 90 (1995) 75
- Recovery and recrystallization of SrTiO₃(100) surface characterized by ion channeling, F. Wang, M. Badaye, K. Ogawa and T. Morishita 90 (1995) 123
- Conversion film formation on titanium anodes in acetonitrile at high voltages, F.

- Schlottig, J. Schreckenbach, D. Dietrich, A. Hofmann and G. Marx 90 (1995) 129
- Titanium dioxide**
- A photoemission study of electron states in Sb-ion implanted $\text{TiO}_2(110)$, A.E. Taverner, A. Gulino, R.G. Egdell and T.J. Tate 90 (1995) 383
- Titanium nitride**
- Conversion film formation on titanium anodes in acetonitrile at high voltages, F. Schlottig, J. Schreckenbach, D. Dietrich, A. Hofmann and G. Marx 90 (1995) 129
- Titanium oxide**
- Surface segregation of Sb in doped TiO_2 rutile, A. Gulino, G.G. Condorelli, I. Fragalà and R.G. Egdell 90 (1995) 289
- XPS oxygen line broadening in lead zirconium titanate and related materials, A. Zomorrodian, A. Mesarwi, N.J. Wu and A. Ignatiev 90 (1995) 343
- Transition metals**
- Photoemission studies on Pt foil implanted by carbon atoms accelerated in a Van de Graaff generator: nature of the interaction between Pt and carbon, R. Sundararajan, G. Pető, E. Koltay and L. Guzzi 90 (1995) 165
- Tungsten**
- Charge transfer processes in $\alpha\text{-WO}_3/\text{Si}$ heterostructure during electro- and photochromism, E.A. Tutov and A.A. Baev 90 (1995) 303
- Vanadium oxide**
- The influence of the substrate material on the growth of V_2O_5 flash-evaporated films, C. Julien, J.P. Guesdon, A. Gorenstein, A. Khelfa and I. Ivanov 90 (1995) 389
- Xenon**
- Silicon surface cleaning using XeF_2 gas treatment, V.S. Aliev, M.R. Baklanov and V.I. Bukhtiyarov 90 (1995) 191
- X-ray diffraction**
- Ferroelectric BaTiO_3 films with a high-magnitude dielectric constant grown on p-Si by low-pressure metalorganic chemical vapor deposition, T.W. Kim, Y.S. Yoon, S.S. Yom and C.O. Kim 90 (1995) 75
- Synthesis of molybdenum nitride $\gamma\text{-Mo}_2\text{N}$ by multipulse laser irradiation of molybdenum in nitrogen, J.D. Wu, C.Z. Wu, Z.M. Song, L.H. Wu and F.M. Li 90 (1995) 81
- Surface studies of oil-seal degradation, G.C. Smith, D. Park, K.J. Titchener, R.E. Davies and R.H. West 90 (1995) 357
- Lateral composition modulation in InGaAsP deposited by gas source molecular beam epitaxy on (100)- and ($h11$)-oriented InP substrates, R.R. LaPierre, B.J. Robinson and D.A. Thompson 90 (1995) 437
- Characterization of the plasma plume and of thin film epitaxially produced during laser ablation of SnSe , R. Teghil, A. Santagata, V. Marotta, S. Orlando, G. Pizzella, A. Giardini-Guidoni and A. Mele 90 (1995) 505
- Zeolites**
- An XPS study of the optimum loading of barium on high-silica MFI zeolite, M.H. Mohamed, M.M. Abdillahi, N.M. Abbas and A.B. Siddiqui 90 (1995) 409
- Zirconium**
- Thermal etching of $\alpha\text{-Zr}$ single-crystal surfaces, H. Zou, G.M. Hood, R.J. Schultz and J.A. Roy 90 (1995) 59
- XPS oxygen line broadening in lead zirconium titanate and related materials, A. Zomorrodian, A. Mesarwi, N.J. Wu and A. Ignatiev 90 (1995) 343

